



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Customer Number: 20277

Kenji YONEDA

Confirmation Number: 2871

Application No.: 10/822,722

Group Art Unit: 2891

Filed: April 13, 2004

Examiner: Everhart, Caridad

For: METHOD FOR FABRICATING SEMICONDUCTOR DEVICE AND SEMICONDUCTOR SUBSTRATE

Mail Stop Amendment  
 Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

- ☒ No additional fee is required.  
☐ Applicant is entitled to small entity status under 37 CFR 1.27  
☐ Also attached:

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	5	20	0	\$50.00 =	\$0.00
Independent Claims	5	6	0	\$200.00 =	\$0.00
Multiple dependent claims newly presented					\$0.00
Fee for extension of time					\$0.00
					\$0.00
Total of Above Calculations					\$0.00

- ☐ Please charge my Deposit Account No. 500417 in the amount of \$0.00. An additional copy of this transmittal sheet is submitted herewith.
- ☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

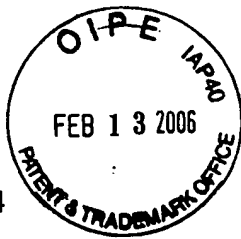
Respectfully submitted,

McDERMOTT WILL &amp; EMERY LLP

Michael E. Fogarty  
 Registration No. 36,139

Please recognize our Customer No. 20277 as our  
 correspondence address.

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 Date: February 13, 2006



Docket No.: 060188-0834

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	Customer Number: 20277
Kenji YONEDA	:	Confirmation Number: 2871
Application No.: 10/822,722	:	Group Art Unit: 2891
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**AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated November 15, 2005, having a three-month shortened statutory period for response set to expire February 15, 2006, please amend the above-identified application as follows.